

DOCKET NO: 230421US26YA

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :  
ANDREJ S. MITROVIC : EXAMINER: AKASH SAXENA  
SERIAL NO: 10/673,501 :  
FILED: SEPTEMBER 30, 2003 : GROUP ART UNIT: 2128  
FOR: SYSTEM AND METHOD FOR :  
USING FIRST-PRINCIPLES  
SIMULATION TO CHARACTERIZE A  
SEMICONDUCTOR MANUFACTURING  
PROCESS

**REQUEST FOR CORRECT INVENTORSHIP UNDER 37 C.F.R. §1.48(1)**

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

In the matter of the above-identified application, Applicant hereby request correction of your records to reflect the following change in inventorship. The omission of the second inventor was inadvertent and such omission occurred without deceptive intent. Please add the following inventor:

Eric J. STRANG  
Residence: Chandler, Arizona  
Citizenship: United States  
Mailing Address: 1081 West Oriole Way, Chandler, Arizona 85248

The processing fee set forth in § 1.17(i) is enclosed herewith.

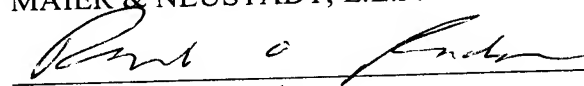
Customer Number

**22850**

Tel: (703) 413-3000  
Fax: (703) 413 -2220  
(OSMMN 07/09)

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, L.L.P.



Steven P. Weihrouch  
Attorney of Record  
Registration No. 32,829  
Ronald A. Rudder, Ph.D.  
Registration No. 45,618

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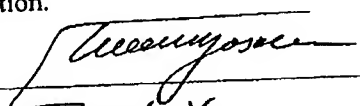
CONSENT OF ASSIGNEE UNDER 37 C.F.R. §1.48(a)(5)

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

On behalf of the Assignee, Tokyo Electron Limited, I consent that Eric J. STRANG should be added as an inventor of the above-mentioned invention.

Date: 10/22/2010

Signature: 

Name: Taynut Yasar

Title: Vice President IP

(On behalf of Tokyo Electron)

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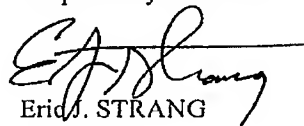
STATEMENT FROM THE INVENTOR UNDER 37 C.F.R. §1.48(c)(2)

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

I hereby state that I am a co-inventor of the above mentioned invention. My inventive contribution is necessitated by amendments which have been made to the claims. The inventorship error occurred without deceptive intent on my part.

Respectfully submitted

  
Eric J. STRANG  
Inventor

Customer Number

22850

Tel. (703) 413-3000  
Fax. (703) 413-2220  
(OSMMN 02/10)